	L#	Search Text	DBs
1	L6	(438/763).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
2	L7	(438/775).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
3	L8	(438/786).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
4	L9	(438/791).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
5	L10	((tri adj2 silane) or trisilane or "Si.sub.3 H.sub.8")	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
6	L11	silicon with (purge or remove) with (nitrid\$6) with (purge or remove)	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
7	L12	("ald" or (atomic adj2 layer))	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
8	L13	((cycl\$4 or cyclically ) near5 deposition) or L12	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
9	L24	257/E21.192	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
10	L25	257/E21.267	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB
11	L26	257/E21.268	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM TDB

	L#	Search Text	DBs
			US-PGPUB; USPAT;
12	L27	257/E21.293	USOCR; EPO; JPO;
			IBM_TDB

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	Ref #	Search Text
155	<b>S</b> 6	S4 with ((tri adj2 silane) or trisilane)
156	<b>S162</b>	((tri adj2 silane) or trisilane)
157	<b>S163</b>	((tri adj2 silane) or trisilane or "Si.sub.3 H.sub.8")
158	<b>S68</b>	S66 same (S62 or S67)
159	S166	(S164 or S165)
160	<b>S165</b>	("ald" or (atomic adj2 layer))
161	S164	((cycl\$4 or cyclically ) near5 deposition)
162	<b>S73</b>	(((cycl\$4 or cyclically ) near5 deposition) or "cld")
163	S168	S165 or S167
164	S167	(((cycl\$4 or cyclically ) near5 deposition) or "cld")
165	S170	S169 same S168

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	DBs
	US-PGPUB; USPAT;
155	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
156	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
157	USOCR; EPO; JPO;
-	IBM_TDB
-	US-PGPUB; USPAT;
158	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
159	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
160	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
161	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
162	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
163	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
164	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
165	USOCR; EPO; JPO;
	IBM_TDB

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	Ref #	Search Text
166	<b>S</b> 173	S171 and S170
167	S171	uniform\$3 same step
168	S169	silicon same S163
169	S174	silicon same S168
170	S172	S171 same S170
171	<b>S</b> 175	S171 same S174
172	S114	(@ad<= "20020719") and S113
173	S176	(@ad<= "20020719" @rlad<= "20020719") and \$175
174	S28	((tri adj2 silane) or trisilane or "Si.sub.3 H.sub.8") and (ammonia or "nh.sub.3") and S26
175	<b>S46</b>	silicon with (purge or remove) with (nitrid\$6) with (purge or remove)
176	<b>S62</b>	((cycl\$4 or cyclically ) near5 deposition)

	<b>DD</b> -
	DBs
	US-PGPUB; USPAT;
166	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
167	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
168	USOCR; EPO; JPO;
	IBM_TDB
,	US-PGPUB; USPAT;
169	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
170	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
171	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
172	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
173	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
174	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
175	USOCR; EPO; JPO;
	IBM_TDB
	US-PGPUB; USPAT;
176	USOCR; EPO; JPO;
	IBM_TDB

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